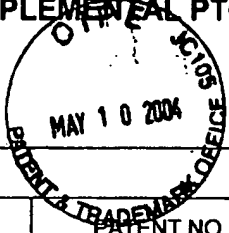


INFORMATION DISCLOSURE CITATION SUPPLEMENTAL PTO-1449		ATTY. DOCKET NO. 07783.0013.NPUS00		SERIAL NO. 10/718,990	
		APPLICANT : Rong-Chang Liang, et al.			
		FILING DATE 11/21/2003		GROUP 1712	



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EX'R INITIAL	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	63020020126249	MM-YYYY				
PA	09/759,212 (WO 02/056097)	11-2001 (07-2002)	Liang, et al	349	187	
PA	US 2002-75556 (09/942,532)	06-2002 (08-2001)	Liang, et al	359	296	
PA	USSN 09/518,488	Filed 03/03/2000	Liang et al	359	296	
PA	USSN 10/444,760	Filed 05/23/2003	Liang et al	359	296	
PA	USSN 10/388,890	Filed 03/14/2003	Liang et al	359	296	
PA	USSN 10/372,027	Filed 02/21/2003	Liang et al	359	296	
PA	USSN 10/351,460	Filed 01/24/2003	Liang et al	359	296	
PA	2002/0196525	12/26/2002	Chen et al.	359	296	
PA	2002/0188053	12/12/2002	Zang et al.	524	474	
PA	2002/0029969	03/14/2002	Yager et al.	204	455	
PA	2002/0018043	02/14/2002	Nakanishi	345	107	
PA	3,229,607	01/18/1966	Battaglia	355	88	
PA	3,612,758	10/12/1971	Evans	348	803	
PA	3,668,106	June 1972	Ota	358	305	
PA	3,689,346	09/05/1972	Rowland	156	245	
PA	3,885,964	05/27/1975	Nacci	430	328	
PA	3,908,052	09/23/1975	Sanders	428	1.5	
PA	3,928,671	Dec 1975	Robusto et al	438	572	
PA	4,071,430	Jan 1978	Liebert	359	241	
PA	4,093,534	June 1978	Carter et al	359	296	
PA	4,190,352	02/26/1980	Bruning	355	119	

SH	4,285,801	Aug 1981	Chiang	252	582	
SH	4,680,103	July 1987	Beilin Solomon I et al	389	296	
SH	4,741,604	05/03/1988	Kornfeld	359	296	
SH	4,741,988	May 1988	Van der Zande et al	480	312	
SH	4,891,245	Jan 1990	Micale	427	213.3	
SH	4,924,257	05/08/1990	Jain	355	53	
SH	5,200,120	04/06/1993	Sakai	264	1.33	
SH	5,274,481	12/28/1993	Kim	349	86	
SH	5,276,438	Jan 1994	DiSanto et al	345	107	
SH	5,279,511	01/18/1994	DiSanto et al	445	24	
SH	5,285,236	02/08/1994	Jain	355	53	
SH	5,380,362	Jan 1995	Schubert	106	493	
SH	5,398,041	03/14/1995	Hyatt	345	88	
SH	5,403,518	Apr 1995	Schubert	252	572	
SH	5,432,526	07/11/1995	Hyatt ABE	528	353	
SH	5,450,220	09/12/1995	Onishi et al.	349	81	
SH	5,480,938	Jan 1996	Badesha et al	525	104	
SH	5,573,711	Nov 1996	Hou et al	252	572	
SH	5,589,100 DLP	12-1996	Grasso, et al			
SH	5,589,100	12/31/1996	Grasso et al.	252	299.01	
SH	5,652,645	07/29/1997	Jain	355	53	
SH	5,699,097	Dec 1997	Takayama et al	347	171	
SH	5,731,860	03/24/1998	Harada et al.	349	158	
SH	5,739,889	04/14/1998	Yamada et al.	349	156	
SH	5,835,174 DLP	11-1998	Clikeman, et al			
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SH	5,843,333	12/01/1998	Hakemi	252	299.5	
SH	5,877,848	03/02/1999	Gillette et al.	355	85	
SH	5,895,541	04/20/1999	Kobayashi et al.	156	240	
SH	5,914,806	Jun 1999	Gordon II et al	359	296	
SH	5,930,026	July 1999	Jacobson et al	359	296	
SH	5,942,154	08/24/1999	Kim et al.	252	299.01	
SH	5,943,113	Aug 1999	Ichihashi	349	187	
SH	5,956,112	09/21/1999	Fujimori et al.	349	156	
SH	5,961,804	Oct 1999	Jacobson et al	204	606	

	5,967,871	Oct 1999	Kaake et al	445	24	
8A	5,976,405 DUF	11-1999	Clikeman, et al			
8A	5,976,405	11/02/1999	Clikeman et al.	252	299.01	
8A	5,978,062	Nov 1999	Liang et al	349	155	
8A	5,985,084	11/16/1999	Summersgill et al.	156	273.7	
8A	5,995,190	11/30/1999	Nagae et al.	349	156	
8A	6,017,584	Jan 2000	Albert et al	427	213.3	
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8A	6,037,058	03-2000	Clikeman, et al			
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8A	6,064,508	May 2000	Forgette et al	359	267	
8A	6,067,185	May 2000	Albert et al	359	296	
8A	6,113,810	Sep 2000	Hou et al	282	572	
8A	6,113,836	09/05/2000	Sakai et al.	264	400	
8A	6,120,588	Sep 2000	Jacobson	106	31.16	
8A	6,120,839	Aug 1998	Comiskey et al	427	213.3	
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8A	6,166,797	12/26/2000	Bruzzzone et al.	349	155	
8A	6,172,798	Jan 2001	Albert et al	359	296	
8A	6,184,856	Sep 1998	Gordon II et al	345	107	
8A	6,191,250	02/20/2001	Aida et al.	528	196	
8A	6,239,896	May 2001	Ikeda	359	240	
8A	6,312,304	Nov 2001	Duthaler et al	445	24	
8A	6,319,381	Nov 2001	Nemelka	204	485	
8A	6,327,072	Dec 2001	Comiskey et al	359	296	
8A	6,337,761	Jan 2002	Rogers et al	359	296	
8A	6,392,785	May 2002	Albert et al	359	296	
8A	6,392,786	May 2002	Albert	359	296	
8A	6,400,430	Jun 2002	Nakao et al	349	89	
8A	6,400,492	06/04/2002	Morita et al.	359	296	
8A	6,512,626	01/28/2003	Schmidt	359	296	
8A	6,514,328	02/04/2003	Katoh et al.	106	31.28	
8A	6,525,865	Feb 2003	Katase	359	296	
8A	6,652,075	Nov 2003	Jacobson	347	515	
8A	6,672,921	Jan 2004	Liang et al	445	24	

PA	20020075556	06/20/2002	Liang et al	359	296	
PA	20020131152	09/19/2002	Liang et al	359	296	
PA	20020182544	12/05/2002	Chan-Park, et al.	430	311	
PA	20030007238	01/09/2003	Liang et al	359	296	
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EX'R INITIAL	PATENT NO.	DATE MM-YYYY	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
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PA	CA 2,340,683	Nat'l Entry 2/14/2001	Canada (Schmidt, F. G.)			<input checked="" type="checkbox"/>	<input type="checkbox"/>
PA	DE 199 27 359.6 (ABS) 4-9 6512 656	Pub. Date 12/21/00	Germany ¹ (Schmidt, F. G.)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
PA	EP 0 990 942	Pub Date 04/05/2000	Europe (Yamanaka)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
PA	EP 1 065 553	Pub Date 01/03/2001	Europe (Ogawa)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
PA	EP 1 089 118 (ABS) 4-9 633 7761	Apr 2001	EPO			<input checked="" type="checkbox"/>	<input type="checkbox"/>
PA	EP 1 195 603	Pub Date 04/10/2002	Europe (Kawai)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
PA (ABS)	JP 6242423	Pub Date 09/02/1994	Japan (Nakai Yuichi) (English abstract included)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
PA (ABS)	JP 64-86116	Pub Date 03/30/1989	Japan (Osamu et al) (English abstract included)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
PA (ABS)	JP 60-205452	Pub Date 10/17/1985	Japan (Hisanori) (English abstract included)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
PA (ABS)	JP 2000 035677	Pub Date 02/02/2000	Japan (English abstract included)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
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PA (ABS)	JP 2001 056653	Pub Date 02/27/2001	Japan (Hayakawa) (English abstract included)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
PA (ABS)	JP 02284126	Pub Date 11/21/1990	Japan (Oshiro) (English abstract included)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
PA (ABS)	JP 59171930	Sep 1984	Japan (English abstract included)			<input type="checkbox"/>	<input type="checkbox"/>
PA (ABS)	JP 02284125	Nov 1990	Japan (English abstract included)			<input checked="" type="checkbox"/>	<input type="checkbox"/>

PH (ABS)	JP 02223934	Sep 1990	Japan (English abstract included)	<input checked="" type="checkbox"/>	<input type="checkbox"/>
SH (ABS)	JP 57104116	Jun 1982	Japan (English abstract included)	<input type="checkbox"/>	<input type="checkbox"/>
SH (ABS)	JP 62-203123	Pub Date Sep 1987	Japan (English abstract included)	<input type="checkbox"/>	<input type="checkbox"/>
PH	WO 98/57226	Dec 1998	PCT	<input type="checkbox"/>	<input type="checkbox"/>
PH	WO 99/08151	Pub Date 02/18/1999	PCT (Bruzzone et al.)	<input type="checkbox"/>	<input type="checkbox"/>
PH	WO 99/53373	Pub Date 10/21/1999	PCT (Drzaic)	<input type="checkbox"/>	<input type="checkbox"/>
SH	WO 99/56171	Nov 1999	PCT	<input type="checkbox"/>	<input type="checkbox"/>
PH	WO 00/03291	Pub Date 01/20/2000	PCT (Jacobson et al.)	<input type="checkbox"/>	<input checked="" type="checkbox"/>
PH	WO 00/36649	Jun 2000	PCT	<input type="checkbox"/>	<input type="checkbox"/>
PH	WO 00/60410	Oct 2000	PCT	<input type="checkbox"/>	<input type="checkbox"/>
SH (ABS)	WO 00/77571	Pub Date 12/21/00	PCT ¹ (Schmidt, F. G.)	<input type="checkbox"/>	<input checked="" type="checkbox"/>
PH	WO 01/67170	Pub Date 09/13/2001	PCT (Liang et al.)	<input type="checkbox"/>	<input type="checkbox"/>
SH	WO 02/01281	Pub Date 01/03/2002	PCT (Liang et al.)	<input type="checkbox"/>	<input type="checkbox"/>
PH	WO 02/56097	Pub Date Jul 2002	PCT (erroneously identified as WO 02/56079 on page 3 of Spec.)	<input type="checkbox"/>	<input type="checkbox"/>
SH	WO 02/65215	Aug 2002	PCT	<input type="checkbox"/>	<input type="checkbox"/>
PH	WO 03/19280	Mar 2003	PCT	<input type="checkbox"/>	<input checked="" type="checkbox"/>

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PH	Comiskey et al., "An Electrophoretic Ink for All-printed Reflective Electronic Displays", Letters to Nature, MIT, The Media Laboratory, 20 Ames Street, Cambridge, MA 02139-4307, USA, May 1998, pp-253-255
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EXAMINER: 800-FR 14. DATE CONSIDERED: 07/15/05

EXAMINER: Initial if citation considered, whether or not the citation conforms with MPEP 609. Draw a line through the citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.

*If an asterisk is placed beside the reference number, a copy is not provided because the reference was previously cited by or submitted to the PTO in a prior application that is identical in the statement and relied upon for an earlier filing date under 35 U.S.C. §120. 37 C.F.R. §1.98 (d).



INFORMATION DISCLOSURE CITATION SUPPLEMENTAL PTO-1449		ATTY. DOCKET NO. 07783.0013.NPUS00		SERIAL NO. 10/718,990			
		APPLICANT : Rong-Chang Liang, et al.					
		FILING DATE: 11/21/2003		GROUP: 1712			
U.S. PATENT DOCUMENTS							
EX'R INITIAL	PATENT NO.	DATE MM-YYYY	NAME	CLASS	SUBCLASS	FILING DATE	
SA	6,304,309	10-2001	Yamanaka et al	349	156		
FOREIGN PATENT DOCUMENTS							
EX'R INITIAL	PATENT NO.	DATE MM-YYYY	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
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EXAMINER: Initial if citation considered, whether or not the citation conforms with MPEP 609. Draw a line through the citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.							
*If an asterisk is placed beside the reference number, a copy is not provided because the reference was previously cited by or submitted to the PTO in a prior application that is identical in the statement and relied upon for an earlier filing date under 35 U.S.C. §120. 37 C.F.R. §1.98 (d).							